

#### ABSTRACT OF THE DISCLOSURE

As a method of fabricating aspherical microstructures, a  
5 protruding microstructure is formed on a substrate, an aspherical-profile  
forming layer is formed on the substrate and the protruding microstructure,  
and the aspherical-profile forming layer is hardened. An aspherical  
profile is formed on the protruding microstructure due to a surface tension  
of the aspherical-profile forming layer in the step of forming the  
10 aspherical-profile forming layer, and the aspherical profile is maintained  
through the step of hardening the aspherical-profile forming layer.